

Docket No.: 2004P00018

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By: 

Date: November 29, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No.	: 10/591,879	Confirmation No.:	N/A
Applicant	: Christofer Hierold et al.		
Filed	: September 5, 2006		
Title	: Force Sensor		
Art Unit	: N/A		
Examiner	: to be determined		
Docket No.	: 2004P00018		
Customer No.	: 24131		

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR § 1.97

Hon. Commissioner for Patents
Alexandria, VA 22313-1450

Sir:

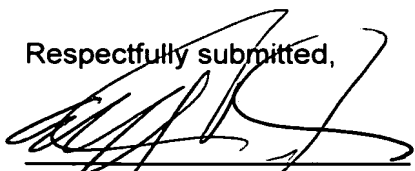
In accordance with 37 CFR § 1.98 copies of the following patents and/or publications are cited herewith:

Tombler et al.: "Reversible electromechanical characteristics of carbon nanotubes under local- probe manipulation", Nature, June 15, 2000;

Husain et al.: "Nanowire- based very- high- frequency electromechanical resonator", Applied Physics letters, August 11, 2003;

Toriyama Toshiyuki et al.: " Piezoresistance measurement on single crystal silicon nanowires", Journal of Applied Physics, January 1, 2003.

Respectfully submitted,


For Applicant

Alfred K. Dassler
52,794

Date: November 29, 2006
Lerner Greenberg Sterner LLP
Post Office Box 2480
Hollywood, FL 33022-2480
Tel: (954) 925-1100
Fax: (954) 925-1101 /bh

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U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEAttorney Docket No.:
2004P00018Applic. No.
10/591,879

Applicant

Christofer Hierold et al.

Filing Date
September 5, 2006Group Art Unit
N/AINFORMATION DISCLOSURE
STATEMENT BY APPLICANT
(37 CFR § 1.98(b))

U.S. PATENT DOCUMENTS

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A						
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						

FOREIGN PATENT DOCUMENT

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES NO
	J						
	K						
	L						
	M						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

N	Tombler et al.: "Reversible electromechanical characteristics of carbon nanotubes under local- probe manipulation", Nature, June 15, 2000
O	Husain et al.: "Nanowire- based very- high- frequency electromechanical resonator", Applied Physics letters, August 11, 2003
P	Toriyama Toshiyuki et al.: " Piezoresistance measurement on single crystal silicon nanowires", Journal of Applied Physics, January 1, 2003

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.